

Docket No.: 060188-0707

**PATENT****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 53080  
Masayuki ENDO, et al. : Confirmation Number: 5344  
Application No.: 10/715,433 : Group Art Unit: 2813  
Filed: November 19, 2003 : Examiner: MITCHELL, James M.  
For: PATTERN FORMATION METHOD

**FAX RECEIVED**

JAN 15 2008

**OFFICE OF PETITIONS****INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
Commissioner for Patents  
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Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being before the mailing date of a first Office Action on the merits. No certification or fee is required.

The references were cited in a corresponding Japanese Office Action and their relevance is discussed therein. A copy of the Japanese Office Action, together with an English language version thereof, is attached for the Examiner's information.

**10/715,433**

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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**Date: January 15, 2008**

**Please recognize our Customer No. 53080  
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SHEET 1 OF 1

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Substitute for form 1449/PTO)				ATT'Y. DOCKET NO. <b>060188-0707</b>		SERIAL NO. <b>10/715,433</b>	
				APPLICANT <b>Masayuki ENDO, et al.</b>			
				FILING DATE <b>November 19, 2003</b>		GROUP <b>2813</b>	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US 5,880,169	03-09-1999	OSAWA et al.	Corresponds to JP 09-323970		
		US					
		US					
		US					
		US					
		US					
		US					
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Code <sup>1</sup> -Number & Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP 9-222724	08-26-1997	JAPAN SYNTHETIC RUBBER CO LTD		JAPAN (w/ Partial English Translation)	
		JP 09-323970	12-16-1997	SHIN ETSU CHEM CO LTD	Corresponds to US 5,880,169	JAPAN (w/ English Abstract)	
		JP 10-120628	05-12-1998	SHIN ETSU CHEM CO LTD		JAPAN (w/ Partial English Translation)	
		JP 10-303114	11-13-1998	NIKON CORP		JAPAN (w/ Partial English Translation)	
		JP 03-192361	08-22-1991	HITACHI LTD		JAPAN (w/ English Abstract)	
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
		Japanese Office Action, with English Translation, issued in Corresponding Japanese Patent Application No. 2003-177884, dated on October 30, 2007					
		SWITKES et al. "Resolution Enhancement of 157 nm Lithography by Liquid Immersion", OPTICAL MICROLITHOGRAPHY XV, Proceedings of SPIE Vol. 4691, pages 459-465 March 5-8, 2002					
EXAMINER				DATE CONSIDERED			

\*EXAMINER: (initial) If reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.